Instituto Tecnonólogico y de Estudios Superiores de Monterrey



A Review on Nano-Fiber Fabrication Methods by Near-Field Electrospinning

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Abstract

Faculty: Nanotechnology

School of Engineering and Sciences

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keywords: nanotechnology, nano-fiber, near-field electrospinning, NFES

1 Summary

TABLE 1.1: Electrospun Polymer Solutions - Solution and Process Parameters

| Polymer(s) | Solvent(s) | NFES Variant | Polymer Solution and Process Properties | Fiber Characterization | Ref. |
|----------------------------|-----------------|---------------------------------|---|------------------------|------|
| Poly(ethylene oxide) (PEO) | Deionized water | Mechano electrospin- ning | PEO Concentration: 1, 2, and 3 wt% Rise in solution conductivity with the increase in PEO concentration Solution Stirring: 24 h of free diffusion followed by 96 h of stirring at 30 rpm 3 mL syringe 27 gauge type 304 stainless steel needle Solution deposition rate: lower than 1 μL/h needle-to-collector distance: 1 mm Collector substrate: Pyrolyzed SU-8 carbon and Si NFES process initiated by an air interference with a glass microprobe tip (1 to 3 μm tip diameter) to overcome the surface tension Time to produce a stable continuous jet: 45 min Polymer jet initiated at 400-600 V and dispensed at 200-400 V Collector linear speed: 10-40 mm/s The voltage turned on when the solution formed a full-sized droplet of 500 μm diameter at the needle tip. | • Diameter: 50-425 nm | [1] |

TABLE 1.2: Electrospun Polymer Solutions - Solution and Process Parameters

| Polymer(s) | Solvent(s) | NFES Variant | Polymer Solution and Process Properties | Fiber Characterization | Ref. |
|--|---|---------------------------------|--|--|------|
| Poly[2-methoxy-5- (2-ethylhexyloxy)- 1,4- phenylenevinylene] (MEH-PPV) with Poly(ethylene oxide) (PEO) | acetonitrile / toluene mixture (65 / 35); acetic acid / toluene (17 / 83); pure toluene | Mechano electrospin- ning | Concentrations: MEH-PPV solution: 10 mg of MEH-PPV in 2 mL of toluene 500 μL of MEH-PPV solution with 250 mg of PEO in 3.5 mL of acetonitrile / toluene (65 / 35) 500 μL of MEH-PPV solution with 250 mg of PEO in 3 mL of acetic acid / toluene (17 / 83) The resulting MEH-PPV/PEO concentration is 1:100 Solution Stirring: MEH-PPV solution stirred for 4 h; PEO solution stirred for 8 h; MEH-PPV/PEO solution stirred and ultrasonically agitated Collector substrate: SiO2/Si (oxide thickness = 800 nm) needle-to-collector distance: 500 μm μm-diameter tip Tungsten spinneret in a 26 gauge needle Solution deposition rate: 50 μL/h Electrostatic voltage: around 1.3 kV x-y stage velocity: 50 cm/s | Distance between adjacent fibers: around 100 μm Fiber diameter: around 100 nm | [2] |

TABLE 1.3: Electrospun Polymer Solutions - Solution and Process Parameters

| Polymer(s) | Solvent(s) | NFES Variant | Polymer Solution and Process Properties | Fiber Characterization | Ref. |
|-------------------------------|------------|---------------------------------|---|---|------|
| Poly(ethylene oxide) (PEO) | Water | Mechano electrospin- ning | 7 wt % PEO aqueous solution Under room temperature at 1 atm needle-to-collector distance: 500 μm needle diameter: outer: 200 μm; inner: 100 μm applied voltage for jet initiation: 1.5 kV applied voltage for fiber deposition: 600 V Mechanical drawing is applied by using a tungsten probe with 1 μm tip diameter to poke inside the meniscus. The probe is then rapidly pulled away from the polymer droplet to activate the continuous electrospinning process polymer jet diameter: 3 μm polymer feed rate: 0.1 μL/h x-y stage velocity: 120 mm/s | 108 <i>m</i> yield in 15 <i>min</i> with a fiber diameter of 709 ± 131 <i>nm</i> Fiber diameter: around 49-74 <i>nm</i> when applied voltage is 800 <i>V</i> | [3] |

TABLE 1.4: Electrospun Polymer Solutions - Solution and Process Parameters

| Polymer(s) | Solvent(s) | NFES Variant | Polymer Solution and Process Properties | Fiber Characterization | Ref. |
|-----------------------------------|-----------------|---|--|------------------------|------|
| Poly(ε- Caprolactone) (PCL) | Not applicable. | Melt Electro- spinning Writing (MEW) | Collector substrate: NCO-sP(EO-stat-PO)-coated glass slide surfaces fibre diameters are between 5 and 30 μm | • 1 • 2 | [4] |

TABLE 1.5: Electrospun Polymer Solutions - Solution and Process Parameters

| Polymer(s) | Solvent(s) | NFES | Polymer Solution and Process Properties | Fiber Characterization | Ref. |
|------------|------------|---------|---|------------------------|--------------|
| | | Variant | | | |
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